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# NOVEL INTERFEROMETRIC TECHNIQUES IN PROFILOMETRY AND SPECTROMETRY

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### Abstract

The work in this thesis is in the fields of profilometry and Fourier transform spectrometry.

Deformation measurement of diffuse objects by phase stepping was achieved by thermal frequency drift in a HeNe laser. The system was easy to construct, required no specialised components, was immune to the effects of piezo-actuator hysteresis, and was capable of producing phase maps in which noise was less than  $1/20\lambda$ .

A method was proposed for measuring absolute surface profile by scanning frequency over the range of a white light source. The coincidence technique of coherence radar was used to measure surface profiles in three dimensions to micron accuracy. Spatial techniques were developed to process the large data set quickly and efficiently.

A novel Fourier transform spectrometer was developed to measure the spectrum of narrowband light sources. Heterodyning techniques gave a resolution of 0.01nm with a free spectral range of  $\approx 2.5\,nm$ . The Sagnac common path design afforded immunity to vibration. The mode structure and mode hopping characteristics of a typical laser diode were measured as a function of diode injection current.

An improved Fourier transform spectrometer was developed. Based on a Michelson interferometer. The instrument could resolve to 0.013nm over a  $\approx 3nm$  free spectral range. Instrument operation was simplified and functionality was extended to non point sources.

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**CHEERS** 

TINA

# Table of Contents

| Chapter    | 1. General Introduction                                     | 1  |
|------------|---|----|
| PART I - O | PTICAL PROFILOMETRY   | 3  |
| Chapter    | 2. Phase Stepping Profilometers                             | 6  |
| 2.1.       | Introduction  | 6  |
| 2.2.       | Theory  | 7  |
| 2.2        | .1. The Phase Stepping Algorithm                            | 7  |
| 2.2        | .2. Phase Stepping by Frequency Scanning                    | 8  |
| 2.2        | .3. Phase Stepping in the Speckle Regime                    | 11 |
| 2.3.       | Dual Michelson Phase Stepping Profilometer                  | 12 |
| 2.3        | .1. Interferometer Design                                   | 12 |
| 2.3        | .2. Feedback Control of the Phase Step.                     | 14 |
| 2.4.       | Results   | 17 |
| 2.5.       | HeNe Laser Driven Phase Stepping Speckle Interferometer     | 18 |
| 2.6.       | Effects of the HeNe Laser                                   | 22 |
| 2.6        | .1. Scan Speed  | 22 |
| 2.6        | .2. Differential Phase Between Adjacent Longitudinal Modes. | 23 |
| 2.7.       | Potential Sources of Error                                  | 24 |
| 2.7        | .1. Frame grabber Acquisition Time                          | 24 |
| 2.7        | 2. Laser intensity fluctuations                             | 24 |
| 2.7        | .3. Air turbulence  | 25 |
| 2.7        | .4. Non-monotonic Frequency Scan                            | 26 |
| 2.7        | .5. Misalignment of the Speckle Fields                      | 26 |
| 2.8.       | Apparatus   | 27 |
| 2.9.       | Results   | 27 |
| 2.10.      | Conclusion  | 30 |
| Chapter    | 3. Coherence Radar Profilometry                             | 32 |
| 3.1.       | Introduction  | 32 |
| 3.2.       | Frequency Scanning Profilometry                             | 33 |
| 3.3.       | Frequency scanning White Light Michelson Interferometer     | 35 |
| 3.3        | .1. Initial Results   | 36 |
| 3.3        | .2. Throughput  | 38 |
| 3.4.       | Coincidence Radar   | 42 |
| 3.4        | .1. Increasing throughput                                   | 43 |
| 3.4        | .2. Dispersion and Speckle                                  | 44 |
| 3.5.       | White light Coherence Interferometer                        | 46 |
| 3.5        | 1. Calibration of the Piezo Stack                           | 50 |

| 3.5.2. Calibrating the Translation Stage                              | 52  |
|---|-----|
| 3.6. Results  | 54  |
| 3.6.1. Spectral Characteristics of the Profilometer                   | 55  |
| 3.6.2. Profile of a Diffuse Target                                    | 56  |
| 3.6.3. Spatial Speckle Detection                                      | 58  |
| 3.7. Conclusion   | 61  |
| Chapter 4. Profilometry Closing Remarks                               | 63  |
| PART II – Fourier Transform Spectrometry                              | 65  |
| Introduction  | 65  |
| Chapter 5. Sagnac Interferometric Spectrometer                        | 68  |
| 5.1. Introduction   | 68  |
| 5.2. Interferometer Design  |     |
| 5.2.1. Heterodyning with Interferometers                              | 70  |
| 5.3. Single Diffraction Grating Wavemeter                             | 72  |
| 5.3.1. Operating Principles   | 72  |
| 5.3.2. Theoretical Development  | 73  |
| 5.3.3. Experimental Implementation.                                   | 74  |
| 5.4. Double Diffraction Grating Wavemeter                             | 75  |
| 5.4.1. Operating Principles   | 75  |
| 5.4.2. Theoretical Development  | 77  |
| 5.4.3. Characterisation of a laser diode                              | 79  |
| 5.5. Double Diffraction Grating Wavemeter Performance and Limitations | 82  |
| 5.5.1. Effects of optical elements                                    | 82  |
| 5.5.2. Data Acquisition System  | 83  |
| 5.5.3. Basic CCD camera operation                                     | 84  |
| 5.5.4. CCD camera modulation transfer function                        | 85  |
| 5.5.5. The Effects of Data Manipulation Methods                       | 86  |
| 5.6. Introduction of a Fibre Feed System                              | 88  |
| 5.6.1. Expected Behaviour   | 89  |
| 5.6.2. Another look at the Laser Diode                                |     |
| 5.7. Conclusion   | 93  |
| Chapter 6. Michelson Interferometric Spectrometer                     | 94  |
| 6.1. Introduction   | 94  |
| 6.2. Single Diffraction Grating Instrument                            | 95  |
| 6.2.1. Theory   | 96  |
| 6.2.2. Data Acquisition   |     |
| 6.2.3. Results  |     |
| 6.3. Michelson Interferometric Spectrometer                           |     |
| 6.4. Theory of operation  |     |
| 6.4.1. Resolution changes with heterodyne frequency                   |     |
| 6.4.2. Resolution changes within the instrument free spectral range.  |     |
| 6.4.3. Effects of an extended source.                                 |     |
| 6.4.3.1. Horizontal resolution limit                                  | 105 |
| 6.4.3.2 Vertical resolution limit                                     | 107 |

| 6.5. Instrument design and construction    |
|--|
| 6.5.1. Overall requirements                |
| 6.5.2. Beamsplitter assembly design        |
| 6.5.3. Diffraction grating holder design   |
| 6.5.4. Assembly                            |
| 6.6. Spectrometer Calibration              |
| 6.6.1. White Light Source                  |
| 6.6.2. Sodium Vapour Lamp                  |
| 6.6.3. Fringe Shape                        |
| 6.7. Results                               |
| 6.7.1. Laser diode spectrum                |
| 6.7.2. Fluorescence from a HeNe laser      |
| 6.8. Limitations                           |
| 6.9. Conclusion                            |
| Chapter 7. Closing Remarks to Spectrometry |
| Appendix 1. Spectrometer design drawings   |
| Appendix 2. References                     |

X